In a measuring chain or a measuring instrument, the sensor is the element that is directly affected by the measurand (1). Specifically, an electric sensing device converts the quantity to be measured into an electric output signal (generally a voltage) (2). Today electric measurement systems have replaced most nonelectric systems. Only in environments where ionizing radiation or explosive atmospheres are present, nonelectric (mechanical, hydraulic, pneumatic) or optical signals may be more suitable (3). The advantages of using electric sensing devices are numerous and are related above all to the current technology in electrical signal elaboration, recording, and transmission. There are, in fact, even sensors that incorporate integrated circuits for electric signal conditioning or modification in a single package and consequently provide outputs more suitable for the following elements of the measurement chain. Moreover, in the automatic control system where the

sensor's outputs have to be elaborated by a numerical processor, it is very easy to convert an analog electric signal to a numerical form.

It is possible to design an electric sensor for measuring any nonelectric quantity. Because of the electronic structure of matter, by selecting appropriate materials, any variation in a nonelectric parameter yields a variation in the electric parameter (3).

Measurand quantities may be grouped on the basis of the form of energy in which the signal is received by the sensor: mechanical, thermal, electrical, magnetic, radiant (optics), or chemical. In Table 1 a limited number of significant examples belonging to each class are reported (4). Often more than one transformation step is required to generate an electric output signal. It is possible to (2) define *primary measurand* quantities directly sensed by electric sensor whereas *secondary measurands* include a combination of primary measurands (5). There are several physical effects that generate electric signals in response to nonelectric influences. It is very difficult to group the countless types of sensing devices. Table 2 gives an interesting summary of the most widely used physical principles of sensing with the electric output and the typical measured quantities (6).

MATERIALS USED FOR SENSING DEVICES

Metals

Metals are characterized by high electric and thermal conductivity, high optic reflectivity, high deformability, plasticity, mechanical tenacity, and high electronic extraction potential. Alloys or intermetallic compounds conserve these qualities to a high degree. Consequently, many sensors operate on the basis of the variation of physical proprieties of pure metals or alloys following variations of external quantities. In general, from the standpoint of sensor design, there are two classes of metals: nonferrous and ferrous. Ferrous metals, like steel, are often used in combination with a magnetic sensor to measure motion, distance, magnetic field strength, etc. Nonferrous metals offer a wide variety of mechanical and electric proprieties but are permeable to magnetic fields and used whenever these fields are not involved. The major use of nonferrous metals is to produce thermoresistances and thermocouples **ELECTRIC SENSING DEVICES** (5). Metals also exhibit piezoresistant effects, but because they are more sensitive to temperature, the production of

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Table 2. Physical Principles of Electric Sensing Devices

is preferred. extrinsic semiconductors, also called doped semiconductors,

Glass is characterized by transparency, hardness, and resistance to most chemicals. The main type of glass used in sen- **SENSOR CHARACTERISTICS** sor technologies is lead alkali, which is a good electric insulator and is used for manufacturing optical windows, prisms, Because sensors provide an interface between the measure-
and nuclear radiation shields. Furthermore, optical fibers can ment system and the outside world, the cho and nuclear radiation shields. Furthermore, optical fibers can ment system and the outside world, the choice of a sensor
be realized from glass (5). Optical fiber sensors can be sepa-
involves evaluating its input-output r be realized from glass (5). Optical fiber sensors can be sepa- involves evaluating its input-output relationship and also all rated into extrinsic and intrinsic types. In extrinsic fiber-optic links with external systems (sensors, sensing process takes place externally to the fiber, directly connected to the sensing device are reported, and the and the fiber itself plays a passive role as a light conduit information path and interaction bet and the fiber itself plays a passive role as a light conduit information path and interaction between the sensor and the (characterized by a very low attenuation factor). In intrinsic other systems are indicated. Naturally (characterized by a very low attenuation factor). In intrinsic other systems are indicated. Naturally, upstream there is the transducers, however, the measurand interacts locally with system to be measured and down stream is the user system.
the light in the fiber by changing a parameter of the fiber. By user system we mean the system to which t the light in the fiber by changing a parameter of the fiber, By user system we mean the system to which the sensor pro-
such as the refractive index, and the fiber in turn modulates vides information. It may of course perf such as the refractive index, and the fiber in turn modulates vides information. It may of course perform other elaborations the light beam propagating through its core (4,7).

are thermoplastic polymers, such as polyester, phenolic, sors are reported, organized on the basis of the systems to
alkyd allyl and enoxy (5) These are characterized by high which they are related. The analysis and compar alkyd, allyl, and epoxy (5). These are characterized by high which they are related. The analysis and comparison of these
flexibility and stability to mechanical stress and can be characteristics among different sensors ca flexibility and stability to mechanical stress and can be characteristics among different sensors can help the user to formed into any desirable shape. Because plastics are excel- choose the most suitable sensor for each p formed into any desirable shape. Because plastics are excellent electrical isolators, different methods are used to provide them with electrical conductive properties required for shielding: lamination with metal foil, painting with conductive paint, metallization, mixing plastics with conductive additives, and building composite plastic parts incorporating metal mesh. For example, piezoelectric plastics are realized by poling them either in high voltage or by corona discharge and depositing metal electrodes on both sides of the plastic film.

Furthermore, polymers are used together with glass or alone to produce optical fiber. The plastic fibers (plastic-plastic or plastic-glass) are more commonly used than glass because it is possible to realize fibers with any refractive index.

Semiconductors

There are relatively few types of intrinsic semiconductors. **Figure 1.** A sensing device and its interactions with the outside Those made of germanium and gallium arsenide are the most world.

strain gauges by using metal alloys rather than pure metals widely used (8). Adding impurities to these materials, forms When selecting a metal for a sensor design, one must con- which are characterized by an increased number of carriers sider its physical proprieties, and also the relative ease of me- (9). In sensor designs the semiconducting materials (intrinsic chanical processing. For example, copper has excellent ther- and extrinsic) are used both as active materials and as pasmal and electric proprieties, yet is difficult to work with. So sive materials. In some cases, the sensing element is constiin many cases aluminum is considered a compromise alterna- tuted by the semiconductor itself (active material). The semitive (5). conducting materials and, in particular, silicon actually exhibit a great number of physical effects which are quite use-**Ceramics** ful for sensor application, for example, photovoltaic, photo-Ceramic oxide materials play an important, steadily increas-

ing role in almost all fields of electronics. In sensor technolocally increas-

gies, ceramics are very useful because of their structural material does not dis **Glass Glass Glass leled standards of purity and perfection.**

links with external systems (6) . In Fig. 1 the physical systems on the sensor output. In the environment system all interfering sources are summarized, and an auxiliary system is re-
quired to operate the sensor (e.g., for the power supply) (6).

The most widely used polymers in sensor-related applications In the following, the most important characteristics of senare thermoplastic polymers such as polyester phenolic sors are reported, organized on the basis of the

Solution Input Range, Overload, Overrange. The sensor's nominal presses the fact that, for a given measurand and a given re-
range indicates the lower limit and the upper limit values of
the measurand between which the s are the extremes of the safety field of the measurand, whereas
the full range of its measurements (6).
the overrange value is the maximum value safety field of the
measurand, implying that the minimum coincides with the
lo

into a measured system always results in modifying the char-
acteristics of the measurand, thereby changing its value from Repeatability may be expressed quantitatively in terms of the its undisturbed state, and thus making a perfect measure the- dispersion characteristics of the results (1). oretically impossible (10). For example, introducing a temper- Reproducibility is the sensor's ability to indicate identical ature sensor into a vessel of liquid may change its tempera- values of the measurand each time a measurement is made, ture (7). Consequently, the sensor manufacturer has to assuming that all environmental conditions are the same for indicate the sensor loading effects. In particular, the sensor each measurement. It is defined as the closeness of agreement input impedance indicates the electric loading. In general, to between the results of measurements of the same measurand limit the electric loading effects, the input impedance of the carried out under changed conditions o limit the electric loading effects, the input impedance of the carried out under changed conditions of measurement.
Sensor must be high compared to the output impedance of the Changes in conditions may include the principl

divided into two very broad categories: contacting sensors and noncontacting sensors (2) . These categories indicate whether tions changed (1) .
or not the sensor must be in direct contact with the measur-
Response Characteristic, Static Calibration. The response or not the sensor must be in direct contact with the measurand. Inability to connect suitably may depend on physical re- characteristic for a sensing device is the relationship between quirements (the fingers cannot reach the point of interest or the input quantity (also called stimulus) and the correspondit is impossible to see inside the container holding the meas- ing output value (also called response) for defined conditions. urand) or on safety considerations (the measurand or its envi- This relationship may be expressed in the form of a mathe-

as static and dynamic. The first describe performance at room manship and other limitations, the real response characteris-
conditions with very slow changes in the measurand and tic rarely coincides with the ideal Consequ conditions with very slow changes in the measurand and tic rarely coincides with the ideal. Consequently, it is neces-
without any shock, vibration, or acceleration. The latter are sary to establish a relationship between without any shock, vibration, or acceleration. The latter are sary to establish a relationship between the sensor response
related to the response of the sensor to variations of the mea-
and the value with its uncertainty related to the response of the sensor to variations of the mea-
surand the value, with its uncertainty, to be assigned to the
surand with time (11). In most measurement systems the
measurand A calibration process helps det surand with time (11). In most measurement systems the measurand. A calibration process helps determine this rela-
quantity to be measured changes so slowly that it is only nec-
tionship. This is a test during which known quantity to be measured changes so slowly that it is only nec-
essary to know the static characteristics of sensors. But the sensor and also called calibration points are applied to the essary to know the static characteristics of sensors. But the measurand, also called calibration points, are applied to the same sensor in the same operating conditions can be defined sensor, and the corresponding output v same sensor in the same operating conditions can be defined sensor, and the corresponding output values are recorded.
in a static or a dynamic regime according to the accuracy re-
The input is changed very slowly over the

Finally it is necessary to emphasize that we regard the all other influential quantities constant. A single performance
sensor as a black box and that we are only concerned with of this test is called a calibration cycle. sensor as a black box and that we are only concerned with of this test is called a calibration cycle. A complete calibration the relationship existing between input and output quanti-
process usually comprises two or more the relationship existing between input and output quanti-
ties, even if more than one conversion step is involved from choice of the number and location of the calibration points ties, even if more than one conversion step is involved from choice of the number and location of the calibration points
and of the number of calibration cycles is very important be-

ty. Accuracy indicates the closeness of agreement between curve (or calibration diagram). On the basis of all of the gath-

Uncertainty characterizes the dispersion of values that Measured System could reasonably be attributed to the measurand. Thus, it ex-
presses the fact that, for a given measurand and a given re-

measurand carried out under the same conditions of measurement. These conditions are called repeatability conditions and **Loading Effects.** The introduction of any measuring device include the same measurement procedure; the same observer; into a measured system always results in modifying the char-
the same location: and repetition over a s Repeatability may be expressed quantitatively in terms of the

Changes in conditions may include the principle of measuresystem to which the sensor is connected (10). ment; the method of measurement; the observer; and the same location, time, and condition of use. Reproducibility may **Mechanical Coupling.** From this viewpoint, sensors can be be expressed quantitatively in terms of the dispersion charac-
vided into two very broad categories: contacting sensors and teristics of the results, and it is nec

ronment may be hazardous) (7). The matical equation, a numerical table, or a graph. An ideal or theoretical response characteristic exists for every sensor, and **Sensing System Sensing System Sensing System Sensing System resents** the value of the stimulus. But because of variations Sensor performance characteristics are generally categorized of materials, design errors, manufacturing tolerances, work-
as static and dynamic. The first describe performance at room manship and other limitations the real The input is changed very slowly over the entire range, first quired (3) .
Finally it is necessary to emphasize that we regard the set of the refugential quantities constant. A single performance and of the number of calibration cycles is very important because they may affect the achievable accuracy for a given to-**Static Characteristic** tal number of measurements. The sensor responses are suit-*Accuracy, Uncertainty, Bias, Repeatability, Reproducibili-* ably fitted against the input values to form the calibration

ered calibration points an uncertainty band, which can vary small changes in the stimulus (1,9).
along with any variation of the measurand, can also be added The sensor threshold is the largest change in a null-stimualong with any variation of the measurand, can also be added The sensor threshold is the largest change in a null-stimu-
to the calibration curve. The value of measurand (y_0) corre- lus that produces no detectable chang sponding to a sensor response (x_0) is obtained as the ordinate sensor. The threshold may depend, for example of the noint of intersection between the calibration curve and tion, and also on the value of the stimulus (1) of the point of intersection between the calibration curve and the straight line parallel to the ordinate axis passing through Almost any sensor has its operating limits. Further in*x*₀. The uncertainty given to the input (Δy_0) is determined by crease of the stimulus does not produce an increase (or determined by the intersection of the crease) of the output, and the sensor goes into a saturati the width of the segment obtained by the intersection of the same line with the uncertainty band (see Fig. 2) $(1-4,9,11)$. zone.

be determined by using two different methods: direct compar- tion curve as a numerical table or a graph, its linear approxiison and indirect comparison (see Fig. 3). In the first case, a mation is furnished. There are different methods for constandard generator furnishes a known stimulus to the sensor structing the line $(2,3,11)$ (see Fig. 4): being calibrated. The values of these stimuli should be at Least ten times more accurate than the sensor. In the indirect
comparison, the calibration test consists of comparing the cal-
ibrating sensor outputs to the outputs of a standard sensor.
In this case an approximate level

Sensor sensitivity refers to the sensor's ability to generate an output response to a given change in the measurand (1). It is *Theoretical-Slope Linearity*. The straight line is referenced expressed as the change in the characteristic of the sensor is not a straight line, the sensitiv- *Terminal-Based Linearity.* The straight line is defined as ity varies with the value of the stimulus (1,2,10). the line that passes through the output corresponding

the input is zero (6). higher input is applied.

Figure 3. Techniques for calibration: (a) direct comparison; (b) indi-

³. terminal-based; 4. end points. rect comparison.

Resolution is defined as the smallest difference between sensor readings that can be clearly distinguished. In other words it is the minimal change of the input necessary to produce a detectable change at the output. When the output signal is digital, the resolution represents the smallest change in analog input that generates a change of one bit. The resolution is sometimes expressed as a fraction of the maximum input value (1,3,6).

The dead band describes the insensitivity of a sensor in a specific range of the input signal. It is defined as the maximum interval through which a stimulus changes in both di-**Figure 2.** An example of a calibration diagram. The rections without producing a change in response. It may depend on the rate of the change. The dead band is sometimes deliberately widened to prevent any change in response for

to the calibration curve. The value of measurand (y_0) corre-
spanned in the response (x_0) is obtained as the ordinate sensor. The threshold may depend, for example, on noise, fric-

In the calibration process the value of the measurand can *Linearity.* Sometimes, rather than expressing the calibra-

-
- *Zero-Based Linearity.* The straight line is also defined by **Sensitivity, Offset, Resolution, Dead Band, Threshold, Saturation** the least square but with the additional restriction that it passes through zero.
	-
	- Offset is the deviation of the output signal from zero when to the lower input and the theoretical output when the

Figure 4. Different strain lines: 1. least-square; 2. theoretical slope;

applied. The and frequency domains.

Another term sometimes used is conformance (or conformity), which indicates the closeness of a calibration curve to a \bullet An underdamped sensor oscillates around its final value specific curve (pormally the theoretical curve) for a nonlinear (y_z) before coming to rest at specific curve (normally the theoretical curve) for a nonlinear sensor $(4,5)$. • An overdamped system comes to a final value without

Hysteresis. Hysteresis is the difference between two output overshoot. values that correspond to the same stimulus depending on the contribution of change be-
direction (increasing or decreasing) and whether that value is
reached. There is a chance that the output corresponding to a
reached. given input depends on whether the previous input was
higher or lower than the present one. That is similar to the
magnetization of ferromagnetic materials (3). Typical causes
for hysteresis are friction and structural cha mum hysteretic error as a percentage of the full-scale output

indicates the sensor's ability to maintain constant metrologi-

sponse exceeds a three cal characteristics in time (1). Short-term stability is mani-

a percentage of (y_2) . cal characteristics in time (1). Short-term stability is manifested as changes in the sensor performance within minutes, Response time describes the time that has to elapse before hours, or even days. The long-term stability may be related the sensor fully responds to the change. It is defined as to aging of the sensor materials, which causes an irreversible the length of time required for the output to rise to a change in its material proprieties. Aging depends greatly on specified percentage of (y_*) (the percentage is typically environmental storage and operating conditions and how well 95% or 98%). the sensor components are isolated from the environment. A special term has been assigned to 63.2% response time: Stability may be quantified in several ways, for example, in the time constant (τ) .
terms of the time over which a metrological characteristic using fixed two persons

Zero-shift is a change in the zero measurand over a specific time interval at room conditions. The zero-measurand output is the output of the sensor under room conditions with nominal excitation and zero measurand applied (1).

Sensitivity shift is a change in the sensor's sensitivity over a specific period at room conditions (1).

Dynamic Characteristics. When an input stimulus varies suddenly, the sensor response does not follow this variation with perfect fidelity. The sensor does not respond instantly to the stimulus change. The sensor's dynamic characteristics can be stated in term of speed of response, velocity limit, slew rate, and recovery time (2,5,11). Speed of response indicates how fast the sensor reacts to changes in the output variable. Slew rate is the maximum rate of change with time of the input for which the output can keep up with the change. Recovery time is the time interval necessary after a specified event for the sensor to resume functioning as specified. **Figure 5.** Different damping characteristics.

End-Point Linearity. The straight line is defined by the For linear sensors other parameters are used to describe real output when the upper and lower input range are the sensor behavior in dynamic conditions. They refer to the

Time Domain. The most commonly used dynamic charac-The nonlinearity error is defined as the maximum deviation
of any calibration point from the corresponding point on a
specified straight line. Normally it is defined as a percentage
of the output range.
of the output rang

-
-
-

- (6,9).
 Stability, Creep. Drift. Zero-Shift. Sensitivity Shift. Stability application (t_0) and the instant (t_1) in which the re-*Stability, Creep, Drift, Zero-Shift, Sensitivity Shift.* Stability application (t_0) and the instant (t_1) in which the re-
dicates the sensor's ability to maintain constant metrologi-
sponse exceeds a threshold value
	-
	-
- terms of the time over which a metrological characteristic α changes by a stated amount or in terms of the change in a
characteristic over a stated time (5).
A sensing device shows drift if there is a gradual change in

t

For underdamped systems other parameters are also used:

- The overshoot is the difference between the maximum output value (y_{max}) and y_{∞} .
- After having fixed a value band at around y_∞ (normally it is equal to 5% of y_{∞}), the settling time is the time interval between t_0 and the instant in which the output remains limited to the previously mentioned band;
- The ringing frequency is the damping oscillation frequency.

With reference to natural response, which is the evolution of the sensor output starting from a not null initial value and *x* without measurand, two parameters are defined, the natural **Figure 7.** A static compensation technique.
Figure 7. A static compensation technique. frequency is the fundamental sinusoidal component of the

Frequency Domain. In the frequency domain a very impor-
tant dynamic characteristic is the frequency response. It is pensated system (13) As a consequence the relationships betant dynamic characteristic is the frequency response. It is pensated system (13). As a consequence the relationships be-
the change of the amplitude and phase of the output as a tween response v and stimulus x can be exp the change of the amplitude and phase of the output as a tween response *y* and stimulus *x* can be expressed as: $y = ax$ function of the frequency of a unit amplitude sinusoidal input. $x + b$ Sometimes to obtain a proportio function of the frequency of a unit amplitude sinusoidal input. $+ b$. Sometimes, to obtain a proportional relationship $y = kx$,
These two curves are, respectively, the module and the phase another compensation stage is add of the so-called Fourier transfer function $[G(\omega)]$ (4). The freof the so-called Fourier transfer function $[G(\omega)]$ (4). The fre-
quency response is displayed graphically (see Fig. 6) as the When the sensing fails to meet the dynamic specifications quency response is displayed graphically (see Fig. 6) as the When the sensing fails to meet the dynamic specifications, plot as a function of the frequency of the sensor amplitude that is, the dead time is too long or equa plot as a function of the frequency of the sensor amplitude that is, the dead time is too long or equally the frequency
output (amplitude diagram), normally using a logarithmic range is too small it is necessary compensate output (amplitude diagram), normally using a logarithmic range is too small, it is necessary compensate for it (15). Hav-
scale, and of the phase displacement between the input sinu-
ing identified the dominant element in scale, and of the phase displacement between the input sinu-
soid and the output sinusoid (phase diagram). Many synthetic obvious method of improving the dynamic response is that of soid and the output sinusoid (phase diagram). Many synthetic obvious method of improving the dynamic response is that of parameters describe the frequency response of a system. The the inherent design, that is, the design parameters describe the frequency response of a system. The the inherent design, that is, the design parameters are varied bandwidth, also called frequency range, indicates the range to improve the dynamic response of such bandwidth, also called frequency range, indicates the range to improve the dynamic response of such an element. Two
of frequencies over which the sensor can be used. It is defined other methods are normally used: open-loop of frequencies over which the sensor can be used. It is defined other methods are normally used: open-loop and closed-loop
as the range of frequencies for which the transfer function is dynamic compensation. In the open-lo as the range of frequencies for which the transfer function is dynamic compensation. In the open-loop technique a linear
within a fixed band (normally 3 dB, 70.7%) of its peak value within a fixed band (normally 3 dB, 70.7%) of its peak value element, with a transfer function in the Laplace domain
and is defined by the lower and upper cutoff frequencies. The $H(s)$ is introduced into the sensor system and is defined by the lower and upper cutoff frequencies. The $H_c(s)$, is introduced into the sensor system, such that the over-
resonant frequency is the frequency corresponding to which all Laplace transfer function $H(s)$ resonant frequency is the frequency corresponding to which all Laplace transfer function $H(s) = G(s)H_c(s)$ fulfils the re-
the module of the frequency response has a maximum value quired condition [Fig. 8(a)]. In the closed-l the module of the frequency response has a maximum value quired condition [Fig. 8(a)]. In the closed-loop, the compensa-
(6).
Sin is obtained by using a high negative feedback [Fig. 8(b)].

Static and Dynamic Compensation Technique. Generally, the
sensor calibration curve is nonlinear, but it may be corrected
by a suitable static compensation technique. One of the most
by a suitable static compensation tec

Figure 6. An example of the (a) amplitude and (b) phase frequency **Figure 8.** Sensor dynamic compensation, using (a) an open-loop techresponse of a sensor. The sensor of a sensor μ and μ a

natural response (14).
 This method is illustrated in Fig. 7, which also shows the re-
 This method is illustrated in Fig. 7, which also shows the re-
 This method is illustrated in Fig. 7, which also shows the re-
 another compensation stage is added, which allows compen-

tion is obtained by using a high negative feedback [Fig. 8(b)].

$$
H(s) = \frac{G(s)}{1 + H_c(s) \cdot G(s)}
$$

 $G(s)H_s(s)H_s(s) \geq 1$ is satisfied, then $H(s) \sim 1/H_s(s)$. This parameters can be of interest: means that, providing the previous condition is respected, changes in *G*(*s*) due to nonlinear effects have a negligible ef- *Operating Life:* it is the minimum length of time over

processors. In static compensation, using a look-up table fied, without changing its performance beyond specified based on the results of the calibration or using an interpola-
tolerances.
tion technique, the microprocessor gives the corresponding in-
 $Cveling Life$. tion technique, the microprocessor gives the corresponding in-

put value for each measured value. Consequently, there is

names examples (or presided partial range examples) put value for each measured value. Consequently, there is
more interest in repeatability than in linearity. As for dy-
namic compensation, the transfer function of the sensor is
stored in the processor memory, and using a technique and the previous output values, the processor gives
the corresponding input value for each output value. The sen-
sor transfer function is obtained by an identification proce-
sor transfer function is obtained by

environmental inputs or (b) a differential system for a linear sensor.

If the amplifier gain is rendered large such that the condition what aspect has to be highlighted. In particular, the following

- fect on the compensated output (13) (Fig. 9). which the sensor will operate, either continuously or Today, compensation is often realized by numerical micro- over a number of on-off cycles, whose duration is speci-
	-

Reliability Characteristics. Reliability characteristics are
those characteristics relating to the useful life of a sensor.
These characteristics can be specified in different ways de-
pending on the sensor type and, for tion lot, has operated maintenance free and within specified tolerances but in its end-use application for a certain number of years. In order to reduce the testing time and consequently the cost, suitable accelerated life tests (tests performed under environmental conditions more severe than normal) can be set up for some kind of sensors. Of course, the results of these kind of tests have to be considered as indicative and have to be verified by a life test under nominal environmental conditions.

> Cycling life tests are usually performed as part of a qualification test when a sensor specification call for full-range or partial range cycling life. Equipment has been designed for rapid and automatic cycling of many categories of sensors.

User System

Output Signal. There are three major categories of data signal forms: analog, carrier, and digital or pulse. In the analog sensor the output signal level is directly correlated to the value of the measurand. In the so-called carrier form the measured value modulates the characteristics of a carrier sinusoid. The amplitude (amplitude modulation AM), the frequency (frequency modulation FM) or the phase relationship with a reference signal (phase modulation PM) of the sensor output signal depends on the measurand. The most widely used modulation is frequency modulation, because the analog signal frequency has great advantages for signal transmission, for example, fail-safeness and easy galvanic separation. Furthermore it is very easy to obtain a digital output from FM (2). A digital signal consists of a series of pulses containing the encoded information corresponding to the input data. The information may be encoded into the amplitude, width, position or frequency of the pulses. Only a few sensors with direct digital output are available (e.g., incremental or coded displacement and angle sensors) because it is mostly necessary to convert the output signals into digital form to **Figure 9.** Compensation for interfering inputs (x') using (a) opposing interface them with digital system. Many sensing devices also environmental inputs or (b) a differential system for a linear sensor. incorporate an a

Output Range. To indicate the output range, the most com- **Environment System**

Output Noise. This is a random fluctuation of the output

signal not correlated to any information. Noise at the sensor

output is caused by internal and external sources, but when

a sensor has to be characterized, only i

Output Impedance. The sensor output impedance is the im-

pedance between the output terminals of the instrument (6).

It may be connected in parallel or in series with the input

It may be connected in parallel or in seri

that the sensor can supply to the user system without de-
creasing its own performance. Sometimes if the sensor out, sensing elements; the influence of ambient electromagnetic creasing its own performance. Sometimes, if the sensor out-
nut is in voltage the maximum deliverable current is indi-
fields on sensor elements and integral circuitry; and the efput is in voltage, the maximum deliverable current is indi-
cated whereas for a current output signal the maximum fects of radiation on various internal sensor elements. cated, whereas, for a current output signal, the maximum fects of radiation on various internal sensor elements.
deliverable voltage or the maximum load impedance values Besides operating environmental conditions, there ar deliverable voltage or the maximum load impedance values operations, there are also conditions, there are also

establish a common mode among different parts of the system with the requirement that no potential variation may occur environmental conditions, called nonoperating environmental along this common node with respect to any point inside the conditions (11) .
node (4) . It is important to know the possible grounding cir-
In the following, the most common environmental effects node (4). It is important to know the possible grounding cir-
cuit to avoid grounding some user system floating points un-
are presented together with the parameter usually used to cuit to avoid grounding some user system floating points unintentionally. express them.

classified as modulating (passive) or self-generating (active). tremes within which the sensor is intended to operate and
Modulating sensors require excitative nower from an external within which all specifications related Modulating sensors require excitative power from an external within which all specifications related to temperature effects source. To produce the output signal, the excitative signal is apply. The maximum temperature is t source. To produce the output signal, the excitative signal is apply. The maximum temperature is the highest (or lowest) modified by the sensing element as a function of the measur-
temperature to which a sensor can be exp modified by the sensing element as a function of the measurand. In self-generating sensors, instead, output power comes damaged or subsequently showing performance degradation from the input, that is they produce an electric output signal beyond specified tolerances. A more genera from the input, that is they produce an electric output signal from their input quantity. For example, a thermocouple is a of specifying thermal effects on performance characteristics is self-generating thermal sensor. It produces an electromag- given by the temperature error, which is the maximum netic force from the difference in junction temperatures, change in output when the temperature is changed from room whereas the resistance of a thermistor changes with tempera- temperature to specified temperature extremes. Analogously, ture. To measure its value, it is necessary to pass a current a temperature error band is defined as the error band applicathrough the thermistor. By using the power supply voltage, it ble over the operating temperature range. For some sensors, generating sensors produce very low output power, whereas shift and thermal sensitivity shift, which cause a parallel dismodulating sensors produce much higher output energies. placement and a slope change, respectively, of the calibration The presence of an auxiliary power source increases the dan- curve. Knowledge of these individual errors is useful when ger of explosion in explosive atmospheres. (2,3,5,9). the prevailing temperature during a measurement procedure

monly used parameter is the full-scale output (FSO). This is
the algebraic difference between the electric output signal
measured, respectively, with the maximum and the minimum
input in the input range. The output overloa

Output Power. This is the maximum value of the power in liquid; corrosive effects of high salt concentration in the sensor can supply to the user system without de-
ambient atmosphere; various effects of measured fluids

are specified. $\overline{}$ other conditions to which a transducer may be exposed, but the sensor is not expected to operate within specified toler-**Grounding.** Sometimes the sensing device is grounded to ances while exposed to them. However, the sensor is expected tablish a common mode among different parts of the system to perform within specified tolerances after e

Auxiliary System Temperature Effects. The operating range is the range of In considering the need for a power supply, sensors can be ambient temperatures, given by their lower and upper exis possible to control overall sensitivity. In fact, normally self- temperature effects are stated only in terms of thermal zero

metric pressure and used where the ambient pressure is very and the differential approach. The first is based on opposing
low (e.g., at high altitude on aircraft) or where the pressure environmental inputs. Suppose that an low (e.g., at high altitude on aircraft) or where the pressure environmental inputs. Suppose that an element is affected by
is very high (far underground or deeply submerged underwa-
ter) significant variation of performan ter), significant variation of performance may arise. Ambient- to the same environmental input [see Fig. 9(a)], is introduced
pressure error is the maximum change in output at any meas- into the system so that the two effe pressure error is the maximum change in output at any meas-
urand value within the sensor's range, when the ambient example of a differential system is shown in Fig. 9(b). As can urand value within the sensor's range, when the ambient example of a differential system is shown in Fig. 9(b). As can
pressure is changed between specified values, usually be-
be seen, two identical sensors are placed to pressure is changed between specified values, usually be- be seen, two identical sensors are placed to sense the measur-
tween room pressure and a lower or higher ambient pressure. and and its opposite. Because both are af tween room pressure and a lower or higher ambient pressure. and and its opposite. Because both are affected by external The pressure error can be stated in terms of an ambient-pres-
quantities which are presented to both w The pressure error can be stated in terms of an ambient-pres- quantities which are presented to both with the same sign, by sure error band. Sometimes the pressure error is referred to calculating the difference between th sure error band. Sometimes the pressure error is referred to calculating the difference between the two outputs, such ef-
as altitude error, and ranges of pressures are stated in terms fects can be eliminated. Naturally, e as altitude error, and ranges of pressures are stated in terms of altitude above sea level (11). be also compensated for by using the previously presented

Acceleration Effects. Quasi-steady-state acceleration of in-
ternal elements of a sensor may act directly on a mechanical
sensing element or its linkage and cause errors in its output.
When a sensor is to be used in an app plication of specified constant acceleration along specified axes. The acceleration effects, in fact, are typically more evi-
dent when the acceleration is applied along one axis of the **BIBLIOGRAPHY** sensor than when it is applied along other axes. This error
can also be reported in terms of acceleration error band (11).
neva: ISO, 1993.
ISO, 1993.

Vibration Effects. Vibration acceleration affects a sensor in

the same manner as steady-state acceleration. Stronger ef-

fects, however, are connected with the frequencies of vibra-

tion. Amplified vibration (resonanc change in output when a vibration level of specified ampli-
tudes and ranges of frequency is applied to the sensor. Conse-
quently it may be necessary to predict the measurand value 7. C. F. Coombs, Jr., Electronic Instrum quently, it may be necessary to predict the measurand value 7. C. F. Coombs, Jr., *most* likely to be observed by the sensor while it is exposed to McGraw-Hill, 1995. most likely to be observed by the sensor while it is exposed to the most severe vibration environment, and then to specify 8. J. Millman and A. Grabel, *Microelectronics,* 2nd ed., Singapore: and verify vibration errors at that value (11) .

Mounting Effects. A sensor's performance may be changed

ring its installation for example, when the mounting sur-

10. E. O. Doebelin, Measurement Systems Application and Design, 4th during its installation, for example, when the mounting sur-
face of the sensor is not evenly machined so that the case
hecomes deformed when all the mounting bardware is tight. 11. H. N. Norton, *Handbook of Transducers*, becomes deformed when all the mounting hardware is tight- 11. H. N. Norton, *Handbook of Transducers, Name and Cliffs, Norton, Handbook of Transducers, Premiie and Cliffs, Name Cliffs, Name Cliffs, Name Cliffs, NJ: 1989.* ened or when the torque applied to the coupling nut on a pressure fitting causes sensing element deformations. Mounting 12. ISO *International Vocabulary of Basic and General Terms in Me*error is the error resulting from mechanical deformation of the sensor caused by mounting the sensor and making all 13. J. P. Bentley, *Principles of Measurement Systems,* 3rd ed., New electrical and measurand connections. Mounting error, obvi- York: Wiley, 1995. ously, is not included in specifications. However, it may be 14. P. H. Mansfield, *Electrical Transducers for Industrial Measure*necessary to verify its absence (11). *ments,* Toronto: Butterworths, 1973.

is known and appropriate corrections to final data are to be **Environmental Effects Reduction Technique.** The most obvimade (11). The contract of environmental parameters of environmental parameters of environmental parame-It is necessary to emphasize that temperature also affects ters is that of isolation, which allows reducing undesirable dynamic characteristics. Consequently, the specifications electric, magnetic, electromagnetic, and mechanical coupling should include corresponding thermal effects. \blacksquare among various parts of the system and between the system and the outside (4).

Pressure Effects. In some sensors calibrated at room baro-
Pressure and used where the ambient pressure is yery and the differential approach. The first is based on opposing high-gain negative feedback and using a feedback system

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- 9. J. W. Gadner, *Microsensors Principles and Applications,* Chiches-
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ELECTRIC SHOCK. See SAFETY SYSTEMS.